J Rubio

List of Publications by Year in descending order

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794141 686830 41 426 13 19 citations h-index g-index papers 42 42 42 337 all docs docs citations times ranked citing authors

#	Article	IF	Citations
1	<i>Cis</i> and <i>trans</i> platinum(<scp>ii</scp>) N-heterocyclic carbene isomers: synthesis, characterization and biological activity. New Journal of Chemistry, 2022, 46, 14221-14226.	1.4	1
2	Molecular Recognition, Transient Chirality and Sulfur Hydrogen Bonding in the Benzyl Mercaptan Dimer. Symmetry, 2021, 13, 2022.	1.1	11
3	Chirality-Puckering correlation and intermolecular interactions in Sphingosines: Rotational spectroscopy of jaspine B3 and its monohydrate. Spectrochimica Acta - Part A: Molecular and Biomolecular Spectroscopy, 2021, 267, 120531.	2.0	1
4	Sulfur hydrogen bonding and internal dynamics in the monohydrates of thenyl mercaptan and thenyl alcohol. Physical Chemistry Chemical Physics, 2020, 22, 12412-12421.	1.3	21
5	Rotational spectroscopy of organophosphorous chemical agents: cresyl and phenyl saligenin phosphates. Physical Chemistry Chemical Physics, 2019, 21, 16418-16422.	1.3	О
6	An Efficient Microkinetic Modeling Protocol: Start with Only the Dominant Mechanisms, Adjust All Parameters, and Build the Complete Model Incrementally. ACS Catalysis, 2019, 9, 4804-4809.	5.5	13
7	15-Hydroxygermacranolides as Sources of Structural Diversity: Synthesis of Sesquiterpene Lactones by Cyclization and Rearrangement Reactions. Experimental and DFT Study. Journal of Organic Chemistry, 2018, 83, 5480-5495.	1.7	2
8	Sulfur Hydrogen Bonding in Isolated Monohydrates: Furfuryl Mercaptan versus Furfuryl Alcohol. Chemistry - A European Journal, 2018, 24, 6564-6571.	1.7	27
9	Rotational spectra of tetracyclic quinolizidine alkaloids: does a water molecule flip sparteine?. Physical Chemistry Chemical Physics, 2017, 19, 17553-17559.	1.3	4
10	A DFT-Based Computational-Experimental Methodology for Synthetic Chemistry: Example of Application to the Catalytic Opening of Epoxides by Titanocene. Journal of Organic Chemistry, 2017, 82, 3760-3766.	1.7	12
11	Physical modeling and implementation scheme of native defect diffusion and interdiffusion in SiGe heterostructures for atomistic process simulation. Journal of Applied Physics, 2011, 109, .	1.1	27
12	Atomistic modeling of defect diffusion and interdiffusion in SiGe heterostructures. Thin Solid Films, 2010, 518, 2448-2453.	0.8	6
13	Comprehensive model of damage accumulation in silicon. Journal of Applied Physics, 2008, 103, .	1.1	16
14	Current Capabilities and Future Prospects of Atomistic Process Simulation. , 2007, , .		0
15	Modeling charged defects, dopant diffusion and activation mechanisms for TCAD simulations using kinetic Monte Carlo. Nuclear Instruments & Methods in Physics Research B, 2006, 253, 63-67.	0.6	19
16	Bimodal distribution of damage morphology generated by ion implantation. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2005, 124-125, 389-391.	1.7	0
17	Dose loss and segregation of boron and arsenic at the Si/SiO2 interface by atomistic kinetic Monte Carlo simulations. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2005, 124-125, 392-396.	1.7	6
18	Comprehensive modeling of ion-implant amorphization in silicon. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2005, 124-125, 383-385.	1.7	4

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19	lon-implant simulations: The effect of defect spatial correlation on damage accumulation. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2005, 124-125, 386-388.	1.7	О
20	Physically based modeling of dislocation loops in ion implantation processing in silicon. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2005, 124-125, 404-408.	1.7	7
21	Fermi-level effects in semiconductor processing: A modeling scheme for atomistic kinetic Monte Carlo simulators. Journal of Applied Physics, 2005, 98, 053709.	1.1	12
22	Physical atomistic kinetic Monte Carlo modeling of Fermi-level effects of species diffusing in silicon. Physical Review B, 2005, 72, .	1.1	27
23	Modeling arsenic deactivation through arsenic-vacancy clusters using an atomistic kinetic Monte Carlo approach. Applied Physics Letters, 2005, 86, 252103.	1.5	31
24	Ion-beam amorphization of semiconductors: A physical model based on the amorphous pocket population. Journal of Applied Physics, 2005, 98, 046104.	1.1	21
25	Ion implant simulations: Kinetic Monte Carlo annealing assessment of the dominant features. Applied Physics Letters, 2004, 84, 4962-4964.	1.5	6
26	Physical modeling of Fermi-level effects for decanano device process simulations. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2004, 114-115, 284-289.	1.7	6
27	Comprehensive, physically based modelling of As in Si. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2004, 114-115, 135-140.	1.7	5
28	Physically based modelling of damage, amorphization, and recrystallization for predictive device-size process simulation. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2004, 114-115, 151-155.	1.7	14
29	A kinetic Monte Carlo annealing assessment of the dominant features from ion implant simulations. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2004, 114-115, 345-348.	1.7	2
30	Atomistic Monte Carlo simulations of three-dimensional polycrystalline thin films. Journal of Applied Physics, 2003, 94, 163-168.	1.1	23
31	Kinetic Monte Carlo simulations: an accurate bridge between ab initio calculations and standard process experimental data. Materials Science in Semiconductor Processing, 2000, 3, 59-63.	1.9	9
32	Monte Carlo Atomistic Simulation of Polycrystalline Aluminum Deposition. Materials Research Society Symposia Proceedings, 1998, 514, 127.	0.1	3
33	Dose effects on amorphous silicon sputtering by argon ions: A molecular dynamics simulation. Journal of Applied Physics, 1997, 81, 1488-1494.	1.1	13
34	Molecular dynamics simulations of ion bombardment processes. Materials Science and Technology, 1997, 13, 893-896.	0.8	1
35	Detailed computer simulation of ion implantation processes into crystals. Materials Science and Technology, 1995, 11, 1191-1193.	0.8	4
36	An improved molecular dynamics scheme for ion bombardment simulations. Nuclear Instruments & Methods in Physics Research B, 1995, 102, 7-11.	0.6	20

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37	Computer simulation of point-defect distributions generated by ion implantation. Nuclear Instruments & Methods in Physics Research B, 1993, 80-81, 172-175.	0.6	5
38	Inâ€Diffusion and Annealing Kinetics of Palladium in Silicon. Journal of the Electrochemical Society, 1993, 140, 868-870.	1.3	12
39	Optical capture cross sections of palladium in silicon. Journal of Applied Physics, 1991, 69, 298-301.	1.1	2
40	Constant-capacitance deep-level optical spectroscopy. Solid-State Electronics, 1989, 32, 287-293.	0.8	4
41	Optical admittance spectroscopy: A new method for deep level characterization. Journal of Applied Physics, 1987, 61, 2541-2545.	1.1	29